

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2211	yokouchi-k\$.in. hara-t\$.in. araki-h\$.in. okumura-t\$.in.	US-PGPUB; USPAT	OR	OFF	2009/04/27 09:09
L2	2211	yokouchi-k\$.in. hara-t\$.in. araki-h\$.in. okumura-t\$.in.	US-PGPUB; USPAT	OR	OFF	2009/04/27 09:19
L3	618	L2 and (wafer semiconductor)	US-PGPUB; USPAT	OR	OFF	2009/04/27 09:19
L4	8	"2004079909" "2004119829" "2004179535"	US-PGPUB; JPO; DERWENT	OR	OFF	2009/04/27 09:46
L5	10	"2000343054" "10056006" "2002246364"	US-PGPUB; JPO; DERWENT	OR	OFF	2009/04/27 09:50
L6	118	engesser-\$.in.	US-PGPUB; JPO; DERWENT	OR	OFF	2009/04/27 09:54
L7	17	"2002075953" "2002246364" "2004119829" "2000343054" "01240682" "2004079909"	JPO; DERWENT	OR	OFF	2009/04/27 10:00
S1	3092	(134/113 156/345.55 134/50 134/52 134/119 134/190 134/902)	US-PGPUB; USPAT	OR	OFF	2006/12/04 12:48
S2	2215	S1 and (wafer semiconductor substrate)	US-PGPUB; USPAT	OR	OFF	2005/11/11 08:47
S3	1314	S2 and (plate shield\$3 cover)	US-PGPUB; USPAT	OR	OFF	2005/11/11 09:12
S4	146	S2 and (top shield\$3 block \$3) adj3 plate	US-PGPUB; USPAT	OR	OFF	2005/11/11 09:06
S5	5	((("6536454") or ("4871417") or ("6431190") or ("20030196683") or ("6405739") or ("20030196683"))).PN.	US-PGPUB; USPAT	OR	OFF	2005/11/11 09:09
S6	1534	yokouchi-k\$.in. hara-t\$.in. araki-h\$.in. okumura-t\$.in.	US-PGPUB; USPAT	OR	OFF	2005/11/11 09:13
S7	356	S6 and (wafer semiconductor)	US-PGPUB; USPAT	OR	OFF	2005/11/11 09:13
S8	22	S7 and (156/345.\$ "134"/\$)	US-PGPUB; USPAT	OR	OFF	2005/11/11 09:15

S9	3153	(spin\$4 turn\$3 rotat\$3) with (wafer semiconductor) same (plate shield cover)	JPO; DERWENT	OR	OFF	2005/11/11 09:17
S10	3153	((spin\$4 turn\$3 rotat\$3) with (wafer semiconductor)) same (plate shield cover)	JPO; DERWENT	OR	OFF	2005/11/11 09:17
S11	484	S10 and (etch\$3 clean\$3 rins\$3)	JPO; DERWENT	OR	OFF	2006/11/28 12:43
S12	0	"10645065"	US-PGPUB; USPAT	OR	OFF	2006/11/28 11:54
S13	1	"10/645065"	US-PGPUB; USPAT	OR	OFF	2006/11/28 11:54
S14	319	macarthur-\$\$.xa.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/11/28 12:44
S15	232	macarthur-s\$.xa.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/11/28 12:44
S16	11249	(edge bead peripher\$2) with (etch\$3 clean\$3 treat\$3 rins\$3) same (wafer\$1 semiconductor)	US-PGPUB; USPAT	OR	OFF	2006/12/04 12:50
S17	7759	(edge bead peripher\$2) with (etch\$3 clean\$3 treat\$3 rins\$3) with (wafer\$1 semiconductor)	US-PGPUB; USPAT	OR	OFF	2006/12/04 12:50
S18	6750	S17 and (shield\$3 block\$3 mask\$3 annular ring clamp\$3)	US-PGPUB; USPAT	OR	OFF	2006/12/04 12:51
S19	2711	S17 same (shield\$3 block\$3 mask\$3 annular ring clamp\$3)	US-PGPUB; USPAT	OR	OFF	2006/12/04 12:53
S20	1336	S19 and (not plasma)	US-PGPUB; USPAT	OR	OFF	2006/12/04 12:53
S21	2	"11330031"	JPO; DERWENT	OR	OFF	2006/12/07 11:39
S22	1773	(atmosphere block\$3 shield\$3) near\$3 (plate member) with (wafer semiconductor)	US-PGPUB; USPAT	OR	OFF	2006/12/07 11:41
S23	23173	yokouchi-k\$.in. hara-t\$.in. araki-h\$.in. okumura-t\$.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/01 12:43
S24	395	yokouchi-kenichi.in. hara-takahashi.in. araki-hiroyuki.in. okumura-tsuyoshi.in. hiraoka-nobuyasu.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/01 12:44

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